

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE BOARD OF PATENT APPEALS
AND INTERFERENCES

Ex parte ROBERT RASMUSSEN and JIANPING P. YANG

Appeal 2008-5804
Application 10/331,591
U.S. Patent Publication 2003/0129415
Technology Center 1700

Decided: October 16, 2008

*Before: FRED E. McKELVEY, Senior Administrative Patent Judge,
and RICHARD TORCZON and MICHAEL P. TIERNEY, Administrative
Patent Judges.*

McKELVEY, Senior Administrative Patent Judge.

DECISION ON APPEAL

1

2 **A. Statement of the case**

3 Micron Technology, Inc. ("**Micron**"), the real party in interest, seeks
4 review under 35 U.S.C. § 134(a) of a final rejection of claims 38-47 as being
5 unpatentable over the prior art.

6 We have jurisdiction under 35 U.S.C. § 6(b).

1 Representative claim 16 reads:

2 A phosphor particle bounded [sic] substrate formed by a
3 method comprising:
4 applying phosphor particles to the substrate;
5 submerging the substrate [with the phosphor particles]
6 into a binder solution; and
7 removing the substrate from the binder solution at a
8 predetermined rate.

9 Panel also remanded so that the examiner could consider whether
10 rejections based on 35 U.S.C. § 102 or 35 U.S.C. § 103 over prior art might
11 be appropriate.

12 On remand, the examiner entered new rejections based on the prior
13 art.

14 2. Appeal 2006-0247

15 In Appeal 2006-0247, the same panel of the Board affirmed a
16 rejection of the claims as being unpatentable over the prior art. *Ex parte*
17 *Rasmussen*, Appeal 2006-0247 (Bd. Pat. App. & Int. Jun. 21, 2006).

18 Representative claim 16 had been amended by changing "submersing"
19 to "immersing":

20 A phosphor particle bounded [sic] substrate formed by a
21 method comprising:
22 applying phosphor particles to the substrate;
23 immersing the substrate [with the phosphor particles] into
24 a binder solution; and

1 removing the substrate from the binder solution at a
2 predetermined rate.

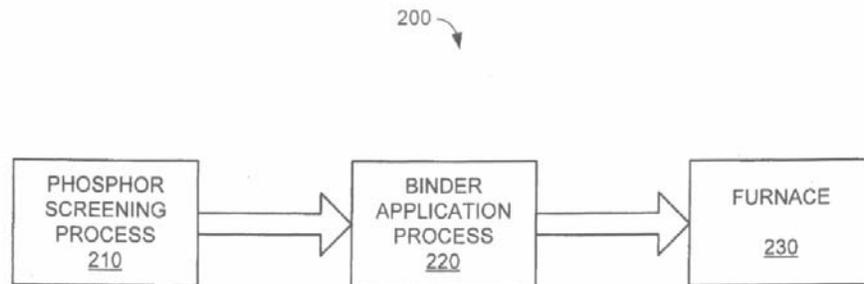
3 Application on appeal

4 The application on appeal was filed on 30 December 2002 and was
5 pending while both appeals were being considered.

6 The invention

7 The invention on appeal relates to a "system" for binding phosphor
8 particles to a substrate in a flat panel display. Appeal Brief, page 3:2-3.

9 According to the specification, the "system" is illustrated in Fig. 2,
10 which is reproduced below. Specification, ¶ 0015.



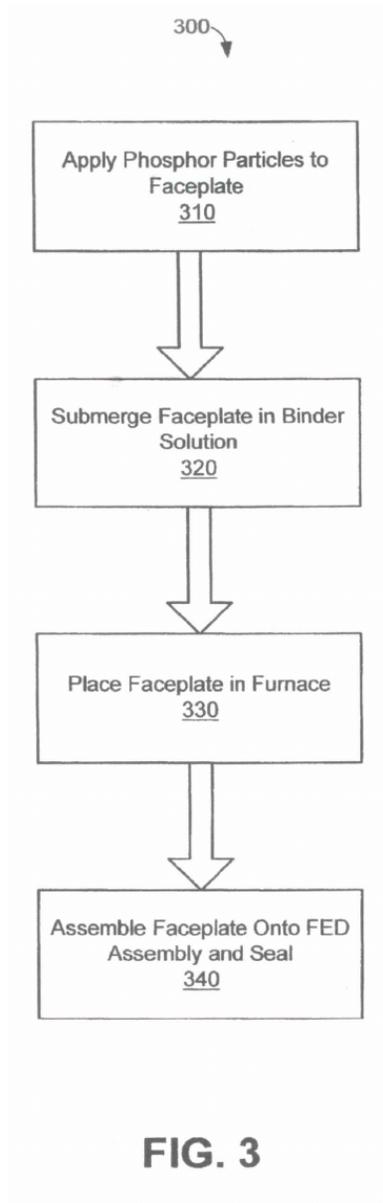
11 FIG. 2

12 Fig. 2 depicts schematically the Micron system

13
14 As will become apparent, the claims before us are not a model of
15 clarity.

16 In order to understand the "system" claims before us, we believe it is
17 necessary to understand the process for using the system.

1 The process for using the system is illustrated in Fig. 3, which is
2 reproduced below. Specification, ¶ 0016.



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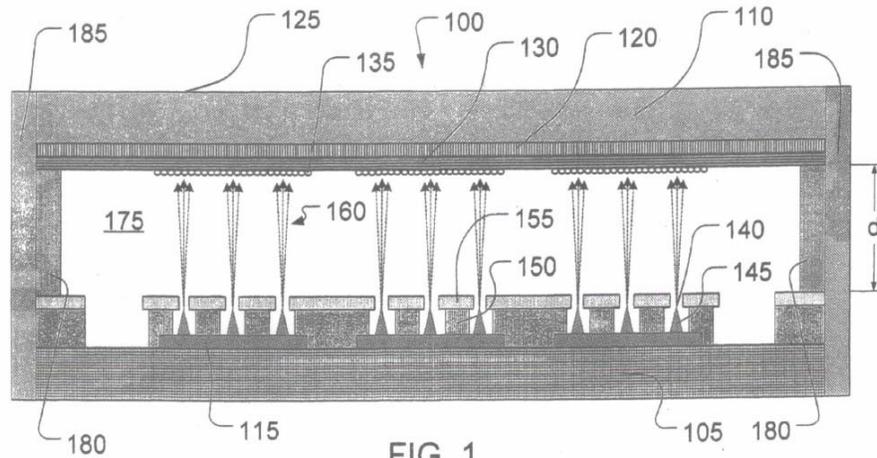
4 Fig. 3 depicts schematically the steps of the Micron process

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6 To understand Fig. 3, it is necessary to have an appreciation of the

7 apparatus shown in Fig. 1.

1 Fig. 1, reproduced below, shows an apparatus in which at least the
2 first step of Micron's process is performed.



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Fig. 1 shows a "first bath" used in Micron's system

According to the specification (¶ 0032 through ¶ 0034), Fig. 3 shows:
a process **300** for binding phosphor particles **135** [Fig. 1] to the
faceplate **110** [Fig. 1] in accordance with one embodiment of
the present invention is provided. The process **300** commences
at block **310**, where the phosphor particles **135** are applied to
the faceplate **110** in a phosphor screening process **210** [Fig. 2]
by electrophoresis, as previously discussed. It will be
appreciated, however, that alternative methods known to those
of ordinary skill in the art may be used in lieu of the
electrophoresis process.

At block **320**, the faceplate **110** is dipped vertically into a
binder solution According to one embodiment, the
faceplate **110** is removed from the binder solution at a slow-

1 controlled rate, which is at a rate of approximately one inch per
2 minute. At this slow-controlled rate, the binder solution
3 provides a uniform distribution over the faceplate **110**, thus
4 improving the adherence of the phosphor particles **135** to each
5 other as well as to the faceplate **110**. As previously indicated,
6 the rate at which the faceplate **110** is extracted from the binder
7 solution may vary depending on the concentration of the
8 solution, for example.

9 Subsequent to removing the faceplate **110** from the
10 binder solution at block **320**, the faceplate is placed in the
11 furnace **230** to set the binder material and the phosphor particles
12 **135** to the faceplate **110** at block **330**, which in one
13 embodiment is approximately 400 °C–700 °C.

14 Claims on appeal

15 Claims 38-47 are on appeal.

16 Claim 38, which we reproduce from the claim appendix of the Appeal
17 Brief, reads [matter in brackets, drawing numbers and references to the
18 specification added]:

19 A system [Fig. 2] for binding phosphor particles **135** to a
20 substrate **110** in a flat panel display, comprising:

21 [1] a first bath **210** containing a non-aqueous solution
22 with phosphor particles dispensed therein, the first bath for
23 receiving the substrate **110** to be immersed in the non-aqueous
24 solution to deposit the phosphor particles **135** thereon [¶ **0020**,
25 **last sentence**];

1 [2] a power supply [**not shown**] coupled to the substrate
2 **110** when the substrate is immersed in the non-aqueous solution
3 and to a counter electrode [**not shown**];

4 [3] a binder solution for binding the deposited phosphor
5 particles;

6 [4] a second bath **220** containing the binder solution, the
7 second bath enabling submersion of the substrate into the
8 binder solution; and

9 [5] a furnace **230** for heating the substrate.

10 Claims 39-47 depend directly or indirectly from claim 38.

11 Observations about claim 38

12 What becomes apparent from reading claim 38 is that it is an
13 aggregation of elements. The relationship of one element to another is not
14 set out in the claim—at least not explicitly:

15 *First*, while a first bath is required, nothing in the claim requires
16 that a substrate be immersed in the bath. All that is required is that the
17 first bath be *capable* of "receiving" a substrate.

18 *Second*, the power supply is required when a substrate is
19 immersed in the first bath. Since there is no requirement that the
20 substrate be immersed in the first bath, it is not clear whether a power
21 supply is only an optional element of the system.

22 *Third*, the second bath contains a binder solution, but does not
23 require that the substrate (presumably with a substrate with phosphor
24 attached) be submersed into the binder solution. All that the claim
25 says is that the second bath be such that a substrate can be submerged

1 therein. Nor does the claim state the relationship in the "system" of
2 the first and second baths.

3 *Fourth*, the claim requires a furnace for heating the substrate,
4 but does not require that the substrate first be immersed in the first
5 bath or be submerged in the second bath prior to heating.

6 Examiner's rejections

7 The examiner rejected all the claims over the prior art. Examiner's
8 Answer, pages 4-7.

9 Prior art

10 The prior art relied upon by the examiner (in patent number order) is:

- 11 (1) Gupton, U.S. Patent 3,681,822.
12 (2) Speigel, U.S. Patent 3,822,454.
13 (3) Rasmussen '773, U.S. Patent 5,762,773
14 (4) Rasmussen '686, U.S. Patent 6,004,686.
15 (5) Xia, U.S. Patent 6,504,291 B1

16 Gupton, Speigel and Rasmussen '773 are prior art under 35 U.S.C.
17 § 102(b).

18 Xia is prior art under 35 U.S.C. § 102(e). Micron has made no
19 attempt to antedate Xia and therefore in this appeal Xia is prior art.

20 While Rasmussen '686 is prior art under 35 U.S.C. § 102(e), it is also
21 prior art under 35 U.S.C. § 102(a). Micron's earliest possible effective filing
22 date is 7 June 2000, the filing date of Micron's parent application. The
23 application on appeal names Rasmussen and Yang as inventors. Rasmussen
24 '686, which names Rasmussen and Cathey as inventors, issued on 21
25 December 1999. Since Rasmussen '686 was issued *before* 7 June 2000, it is

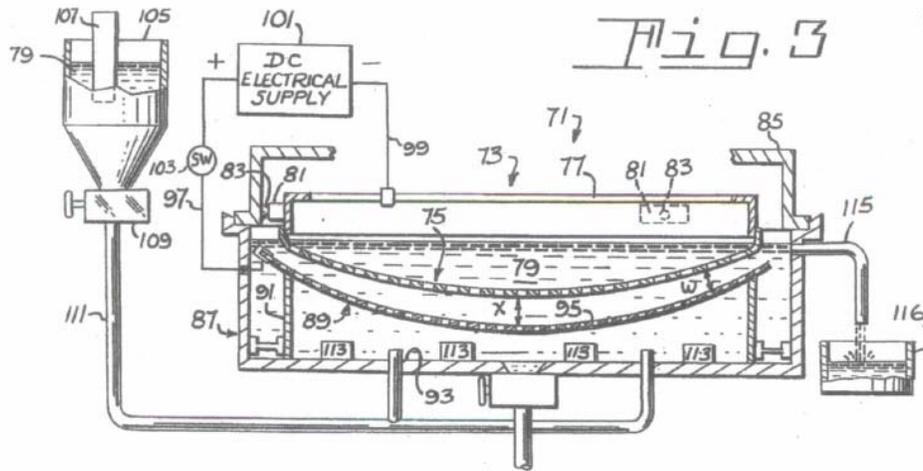
1 prior art under 35 U.S.C. § 102(a). This discussion of the prior art status of
2 Rasmussen '686 is in response to Micron's argument concerning the "non-
3 prior art" status of Rasmussen '773. Appeal Brief, page 9. Given that
4 Rasmussen '773 was issued on 9 June 1998, which is more than one year
5 prior to 7 June 2000, and is therefore prior art under 35 U.S.C. § 102(b), it
6 appears Micron may have intended to call into question the prior art status of
7 Rasmussen '686. Assuming, as Micron asserts in its Appeal Brief (page 9)
8 that Rasmussen '686 invention and the invention involved in the appeal have
9 always been owned by Micron, § 103(c)(1) does not preclude use of
10 § 102(a) art against Micron. Micron has made no attempt to antedate
11 Rasmussen '686. Accordingly, in this appeal, Rasmussen '686 is prior art.
12 To complete the discussion, we note that in Appeal 2004-1865, the panel
13 pointed out that a Janning patent relied upon by the examiner was prior art
14 under 35 U.S.C. § 102(a), as well as § 102(e). *Ex parte Rasmussen*, Appeal
15 2004-1864, slip op. at 2 n.1.

16 What will become apparent upon a consideration of the five prior art
17 references cited by the examiner is that every element in the claimed
18 "system" is known and is being "used" by Micron for its intended purpose to
19 achieve a predictable result. Micron does not rely on any evidence of
20 unexpected results.

21 [1] The first bath

22 The prior art of record reveals that "baths" into which are immersed
23 substrates for the purpose of placing phosphors thereon are known—one
24 might say notoriously old.

1 A review of Fig. 3 of Spiegel, reproduced below confirms that the
2 baths are known.



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4 Fig. 3 shows a bath for depositing phosphors on a substrate
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6 Substrate **75** is immersed in coating suspension **79** in which phosphors
7 are electrophoretically coated on the substrate. Col 7:6-50.

1 Another example of a "first bath" is shown in Fig. 3 of Rasmussen
2 '773, reproduced below.

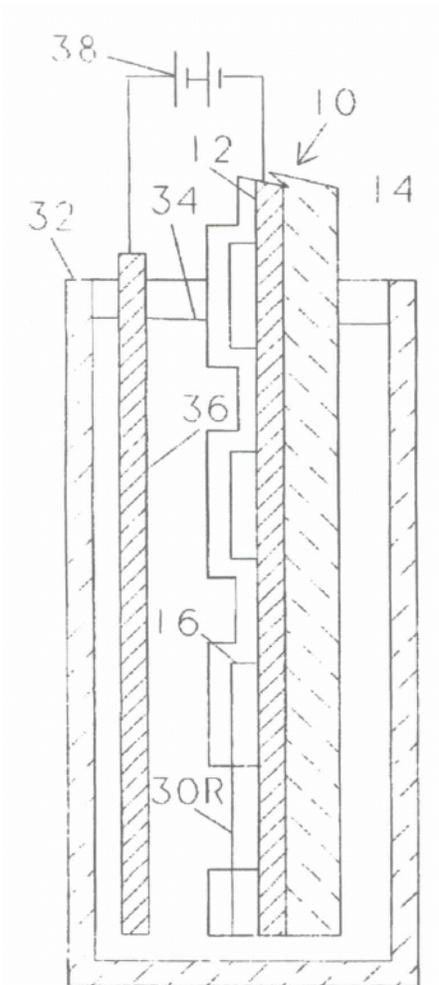


FIG. 3

3
4 Fig. 3 depicts an apparatus for placing phosphor on a substrate
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6 Rasmussen '773 Fig. 3 shows a "first bath" in which phosphor **30R**
7 is deposited on a faceplate **10** while the faceplate is immersed in a bath
8 having an appropriate electrolyte **34**. Col. 3:6-14.

1 Rasmussen '686 reveals to one skilled in the art that the solution used
2 to apply phosphor to a substrate is preferably a non-aqueous liquid.
3 Col. 5:12-13.

4 [2] The power supply

5 A power supply coupled to the substrate and a counter electrode is a
6 conventional combination of elements used in a process for depositing
7 phosphor on a substrate. *See* (1) Spiegel, Fig. 3, element **101**, and the
8 elements to which it is coupled, and col. 8:7, (2) Rasmussen '773, Fig. 3,
9 element **38**, and the elements to which it is coupled, and col. 3:13, and
10 (3) Rasmussen '686, col. 6:9-19.

11 [3] The binder solution

12 The use of a binder solution to firmly attach a phosphor to a substrate
13 is known. *See* (1) Rasmussen '773, col. 4:25-32, (2) Spiegel, col. 8:52-55,
14 and (3) Rasmussen '686, col. 5:21-32.

15 [4] The second bath

16 The prior art reveals that the binder solution can be applied in
17 a separate step after the phosphor is deposited on the substrate. *See*
18 (1) Rasmussen '686, col. 5:27 and (2) Spiegel, col. 8:52-55 ("[a]fter the
19 electrophoretic deposition of the ... [phosphor], a second coating **61** of a
20 binder material is next applied ... by dipping or immersing only the domed ...
21 portion 23 ... into a vat ... containing the second coating binder material.").

22 [5] Heating

23 A heating step is conventional step in this art. To perform the
24 step, a heater is necessary. *See* (1) Rasmussen '686, col. 5:47-51 and
25 (2) Rasmussen '773, col. 4:33-42.

1 Xia

2 As Micron acknowledges (Appeal Brief, page 9), Xia reveals that the
3 use of indium nitrate (claim 40 on appeal) and cerium nitrate (claim 41 on
4 appeal) as electrolytes is well known in the art. Col. 6:31-37.

5 Gupton

6 As Micron acknowledges (Appeal Brief, pages 9-10), Gupton reveals
7 that the use of thorium nitrate (claim 42 on appeal) as an electrolyte is well
8 known in the art. Col. 4:16.

9 Rebuttal evidence

10 Micron does not rely on any rebuttal evidence.

11 **C. Discussion**

12 Examiner's prior art rejections

13 The examiner has rejected claims (1) under 35 U.S.C. § 102 over
14 Rasmussen '686 and Rasmussen '773 and (2) under 35 U.S.C. § 103 over
15 various combinations Rasmussen '773 and Spiegel, Xia and Gupton.

16 1. Anticipation over Rasmussen '686

17 Since we agree with the examiner that the claimed subject matter
18 would have been obvious over the prior art, we do not reach the anticipation
19 rejection based on Rasmussen '686.

20 2. Anticipation over Rasmussen '773

21 Since we agree with the examiner that the claimed subject matter
22 would have been obvious over the prior art, we do not reach the anticipation
23 rejection based on Rasmussen '773.

1 *Salvage Co.*, 396 U.S. 57, 59-60 (1969); *Reckendorfer v. Faber*, 2 Otto
2 (92 U.S.) 347, 356 (1875) (involving a pencil with a erase on the non-
3 writing end where the erase cannot be used at the same time the writing end
4 is used).

5 Micron has presented essentially one merits argument to counter the
6 examiner's rejection under 35 U.S.C. § 103. Micron says Rasmussen '773
7 does not describe the "second" bath. Appeal Brief, page 9. Micron does not
8 deny that coating the binder in a second step is known. *See, e.g.*, Rasmussen
9 '686, col. 5:27. Micron concedes, as it must, that "Speigel describes the use
10 of a bath to deposit a binder solution." Appeal Brief, page 9. Missing from
11 Micron's argument is any explanation why use of the Speigel bath would not
12 have been considered by one skilled in the art as being an "other suitable
13 method" described in Rasmussen '773. Use of the Speigel bath as an "other
14 suitable method" would have been well within the ordinary skill of the art.
15 After all, one skilled in the art would simply have been using a known
16 Speigel method in the manner suggested by Rasmussen '773. It follows that
17 Micron has failed to show that the examiner erred in rejecting claims 38-39
18 and 43-47 under 35 U.S.C. § 103 over the prior art.

19 With respect to claims 40-42, Micron admits that the prior art shows
20 the claimed electrolytes and makes no additional arguments concerning the
21 separate patentability of those claims over the prior art. In this appeal,
22 claims 40-42 fall with claim 38. 37 C.F.R. § 41.37(c)(1)(vii).

23 We have considered Micron's remaining arguments and find none that
24 warrant reversal of the examiner's § 103 rejection. *Cf. Hartman v.*
25 *Nicholson*, 483 F.3d 1311, 1315 (Fed. Cir. 2007).

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1 **D. Decision**

2 Upon consideration of the appeal, and for the reasons given herein,
3 it is

4 ORDERED that the decision of the examiner rejecting
5 claims 38-47 under 35 U.S.C. § 103 over the prior art is *affirmed*.

6 FURTHER ORDERED that no time period for taking any
7 subsequent action in connection with this appeal may be extended under
8 37 C.F.R. § 1.136(a)(1)(iv) (2008).

AFFIRMED

ack

cc:

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